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PATENT
Acy. DEL AMAT/5182/DISPLAY/AKT/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Shang, et al.

Serial No.: 10/024,985

Confirmation No.: 4811

Filed: December 18, 2001

**For: Full Glass Substrate
Deposition in Plasma
Enhanced Chemical Vapor
Deposition**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

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Group Art Unit: 1763

Examiner, Anna M. Crowell

**CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8**

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number (703) 872-9306 to the attention of the named Examiner, on the date below.

Date 12/13/04

Leo J. Zuck
Signature

PETITION FOR ONE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.138(a) to grant a one-month extension of time to and including December 13, 2004, in which to file the Continuation Application (copy coversheet attached).

This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$120.00 and any additional fees which may be required for this submission to Deposit Account No. 20-0782/5162/KMT.

Respectfully submitted,

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